

# Fabrication of 1D Te/2D ReS<sub>2</sub> Mixed-Dimensional van der Waals *p-n* Heterojunction for High-Performance Phototransistor

Jia-Jia Tao, Jinbao Jiang, Shi-Nuan Zhao, Yong Zhang, Xiao-Xi Li, Xiaosheng Fang, Peng Wang, Weida Hu, Young Hee Lee,\* Hong-Liang Lu,\* and David-Wei Zhang



Cite This: *ACS Nano* 2021, 15, 3241–3250



Read Online

ACCESS |



Metrics & More



Article Recommendations



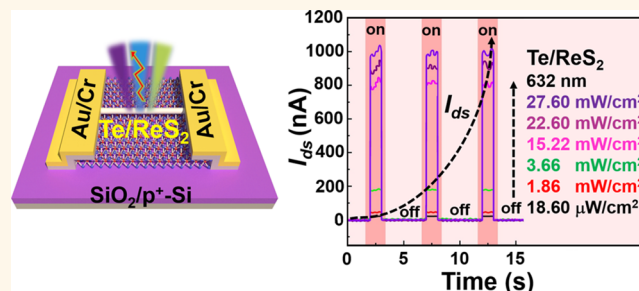
Supporting Information

**ABSTRACT:** The superior optical and electronic properties of the two-dimensional (2D) rhenium disulfide (ReS<sub>2</sub>) makes it suitable for nanoelectronic and optoelectronic applications. However, the internal defects coupled with the low mobility and light-absorbing capability of ReS<sub>2</sub> impede its utilization in high-performance photodetectors. Fabrication of mixed-dimensional heterojunctions is an alternative method for designing high-performance hybrid photodetectors. This study proposes a mixed-dimensional van der Waals (vdW) heterojunction photodetector, containing high-performance one-dimensional (1D) *p*-type tellurium (Te) and 2D *n*-type ReS<sub>2</sub>, developed by depositing Te nanowires on ReS<sub>2</sub> nanoflake using the dry transfer method. It can improve the injection and separation efficiency of photoexcited electron–hole pairs due to the type II *p-n* heterojunction formed at the ReS<sub>2</sub> and Te interface. The proposed heterojunction device is sensitive to visible-light sensitivity (632 nm) with an ultrafast photoresponse (5 ms), high responsivity (180 A/W), and specific detectivity (10<sup>9</sup>), which is superior to the pristine Te and ReS<sub>2</sub> photodetectors. As compared to the ReS<sub>2</sub> device, the responsivity and response speed is better by an order of magnitude. These results demonstrate the fabrication and application potential of Te/ReS<sub>2</sub> mixed-dimensional heterojunction for high-performance optoelectronic devices and sensors.

**KEYWORDS:** photodetector, visible light, photoresponsivity, ReS<sub>2</sub> nanoflake, Te nanowires, van der Waals heterojunction

## INTRODUCTION

The structures and optoelectronic properties<sup>1–4</sup> of the atomically thin-layered two-dimensional transition metal dichalcogenides (2D TMDs) make it suitable for photodetector application.<sup>5–8</sup> For photoelectronic applications, rhenium disulfide (ReS<sub>2</sub>) is the most investigated among the 2D TMDs materials. It has weak interlayer coupling, direct band gap independent of thickness, distorted 1T structure, and low symmetry that enables application in the fabrication of photodetectors and sensors.<sup>9–11</sup> For ReS<sub>2</sub> photodetectors, the highest photoresponsivity (*R*) and detectivity (*D*) of 16.14 A/W and 1.30 × 10<sup>10</sup> Jones, respectively, were achieved in previous studies.<sup>12–15</sup> However, the low mobility of ReS<sub>2</sub> hampers the successful integration of ReS<sub>2</sub>-based optoelectronic devices.<sup>16</sup> Many factors determine the mobility of ReS<sub>2</sub> devices, including the scattering of carriers, substrate phonons, interfacial charged impurities, electron–photon coupling,



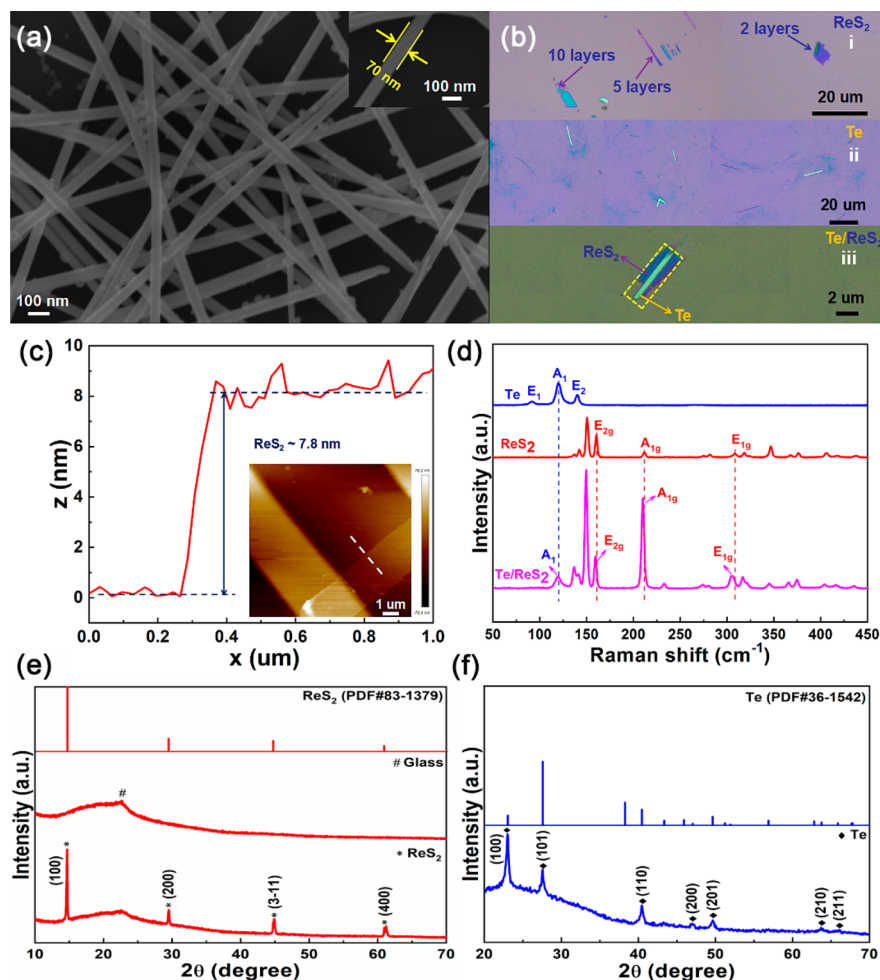
absorbents on the surfaces, and absorption of oxygen and water molecules in the process of device construction.<sup>17,18</sup> In addition, the reduction in the optical absorption of ReS<sub>2</sub> is due to the one-atomic-layer thickness, which makes such monolayer devices inactive in actual application.<sup>19</sup> Thus, improving the performance of the ReS<sub>2</sub> has garnered a lot of attention. Mukherjee et al. presented a multilayer ReS<sub>2</sub>/Si *n-p* heterojunction with improved photoresponsivity of 33.47 A/W and operation time of 80 μs.<sup>20</sup> Lodha et al. designed WSe<sub>2</sub>/ReS<sub>2</sub>-based type-II *p-n* heterojunction photodetector, sensitive

**Received:** November 25, 2020

**Accepted:** February 2, 2021

**Published:** February 5, 2021





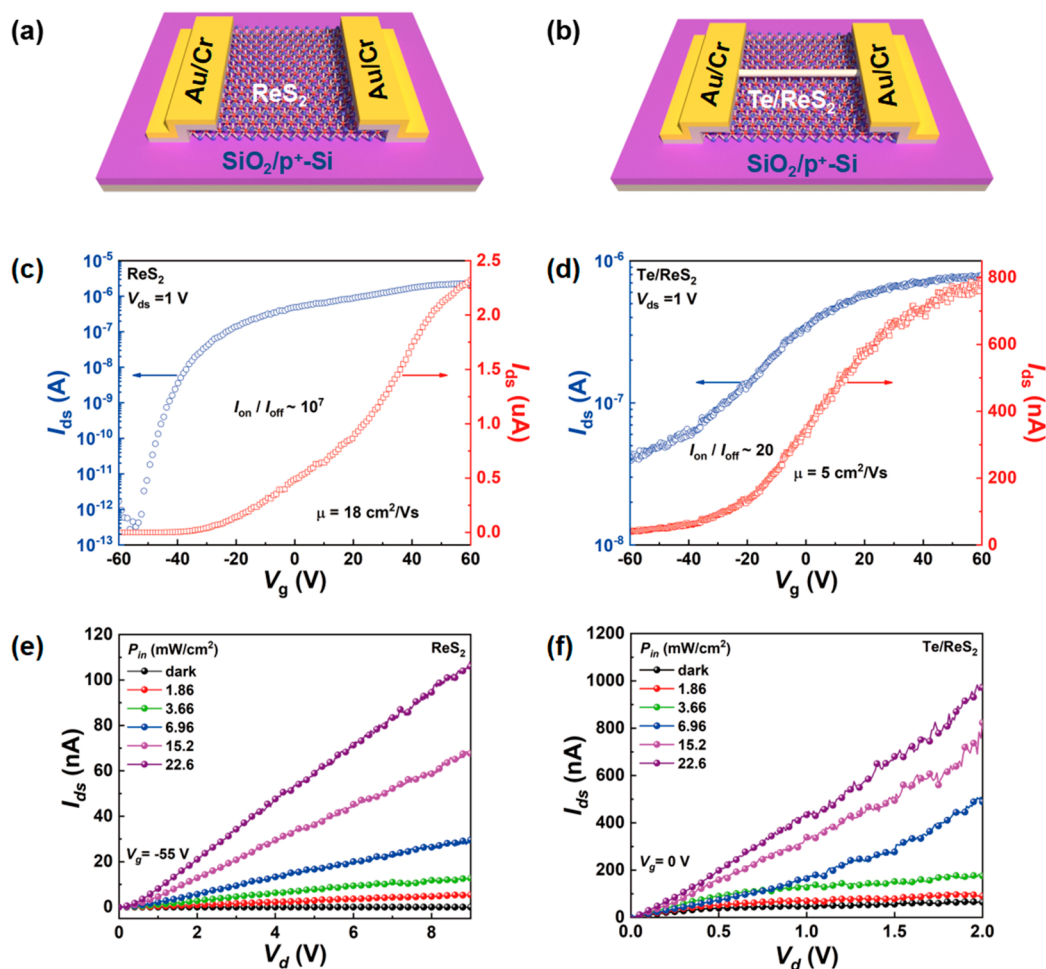
**Figure 1.** Characterizations of 1D Te/2D ReS<sub>2</sub> mixed-dimensional heterojunction. (a) SEM image of Te NWs. Inset: corresponding enlarged images of the single Te NW. (b) Optical microscope images of (i) 2D ReS<sub>2</sub> NFs with different thicknesses, (ii) single 1D Te NWs of different lengths, and (iii) typical 1D Te/2D ReS<sub>2</sub> mixed-dimensional heterojunction. (c) Typical cross-sectional height profile of the exfoliated ReS<sub>2</sub> NF from the AFM image along the white dashed line shown in the inset. (d) Raman spectra of the pristine Te NWs, ReS<sub>2</sub> NFs, and 1D Te/2D ReS<sub>2</sub> mixed-dimensional heterojunction. XRD patterns of (e) the obtained ReS<sub>2</sub> NFs and (f) Te NWs.

to IR light with the ultrafast response time of 5  $\mu$ s and high responsivity of 3 A/W.<sup>21</sup> Lee et al. reported a Black Phosphorus (BP)/ReS<sub>2</sub>-based type-III *p-n* heterojunction diode with photoresponsivity of 8 mA/W and external peak quantum efficiency of 0.3%.<sup>22</sup> Lee et al. combined graphene with ReS<sub>2</sub> to fabricate a strong light absorption photodetector with outstanding detectivity of 10<sup>13</sup> Jones, photoresponsivity of 10<sup>5</sup> A/W, and responsivity of less than 30 ms.<sup>23</sup>

Thus far, only a few studies have focused on the ReS<sub>2</sub> based mixed-dimensional hybrid van der Waals (vdW) heterojunction. Recently, Jariwala et al. proposed mixed-dimensional vdW heterojunctions for overcoming the limitation of electronics of 2D materials.<sup>24</sup> Many research studies have investigated such mixed-dimensional vdW heterojunctions for as an alternate platform for electronics and optoelectronics due to flexibility and high performance. Hu et al. achieved a broadband self-powered photodetector with sensitivity ranging from the UV to visible region by mixed-dimensional 1D Se-2D InSe vdW heterojunction.<sup>25</sup> Ye et al. presented a high-performance dual-channel phototransistor based on a 1D Se/2D ReS<sub>2</sub> heterojunction developed using chemical vapor deposition.<sup>26</sup> Zhang et al. designed 0D-2D mixed vdW heterojunctions of perovskite quantum dots and MoS<sub>2</sub>

monolayer for the high-performance phototransistor.<sup>27</sup> Seo et al. investigated the optoelectronic characterization of the MoSe<sub>2</sub>-WSe<sub>2</sub>-MoSe<sub>2</sub> mixed 2D-2D-2D device, which has a high photoresponsivity.<sup>28</sup> Such mixed-dimensional vdW heterojunctions offer exploration possibilities for highly responsive and special optoelectronic applications.

Tellurium (Te) is a *p*-type semiconductor, a promising material, with high mobility,<sup>29</sup> photoconductivity,<sup>30</sup> piezoelectricity,<sup>31</sup> and thermoelectricity.<sup>32</sup> Though, the single-atomic chain or the few-atomic chains in the Te crystal interacts due to the weak vdW of anisotropic atomic structure.<sup>33</sup> This one-dimensional (1D) vdW crystal structure along with physical properties and stability allows Te application in electronics, optoelectronics, and energy devices. For instance, Zhou et al. demonstrated that Te with high mobility and a developed photodetector exhibits high gain and wider operational bandwidth.<sup>34</sup> Javey et al. also fabricated Te on the Au/Al<sub>2</sub>O<sub>3</sub> substrate for high-performance short-wave infrared photodetector.<sup>35</sup> Zhai et al. assessed a hydrogen-assisted strategy for preparing Te, and the phototransistor was developed with high-performance gate-dependent photoresponsivity.<sup>36</sup> Besides, the 1D Te metal-semiconductor is also promising for mixed-dimensional vdW heterojunctions, but



**Figure 2.** Schematic structure, transfer, and output characteristics of ReS<sub>2</sub> and Te/ReS<sub>2</sub> FETs under dark and light conditions. Schematic structure of (a) ReS<sub>2</sub> and (b) Te/ReS<sub>2</sub> phototransistors. (c,d)  $I_{ds}$ – $V_g$  curves of FETs at  $V_d = 1$  V in the dark. (e,f)  $I_{ds}$ – $V_d$  curves with variable light power intensity (632 nm) at  $V_g = -55$  V for ReS<sub>2</sub> and 0 V for Te/ReS<sub>2</sub> FETs. Figure S3a–c depict the  $I_{ds}$ – $V_d$  curves of FETs at  $V_g$  of 0 V to reveal the contact behaviors.

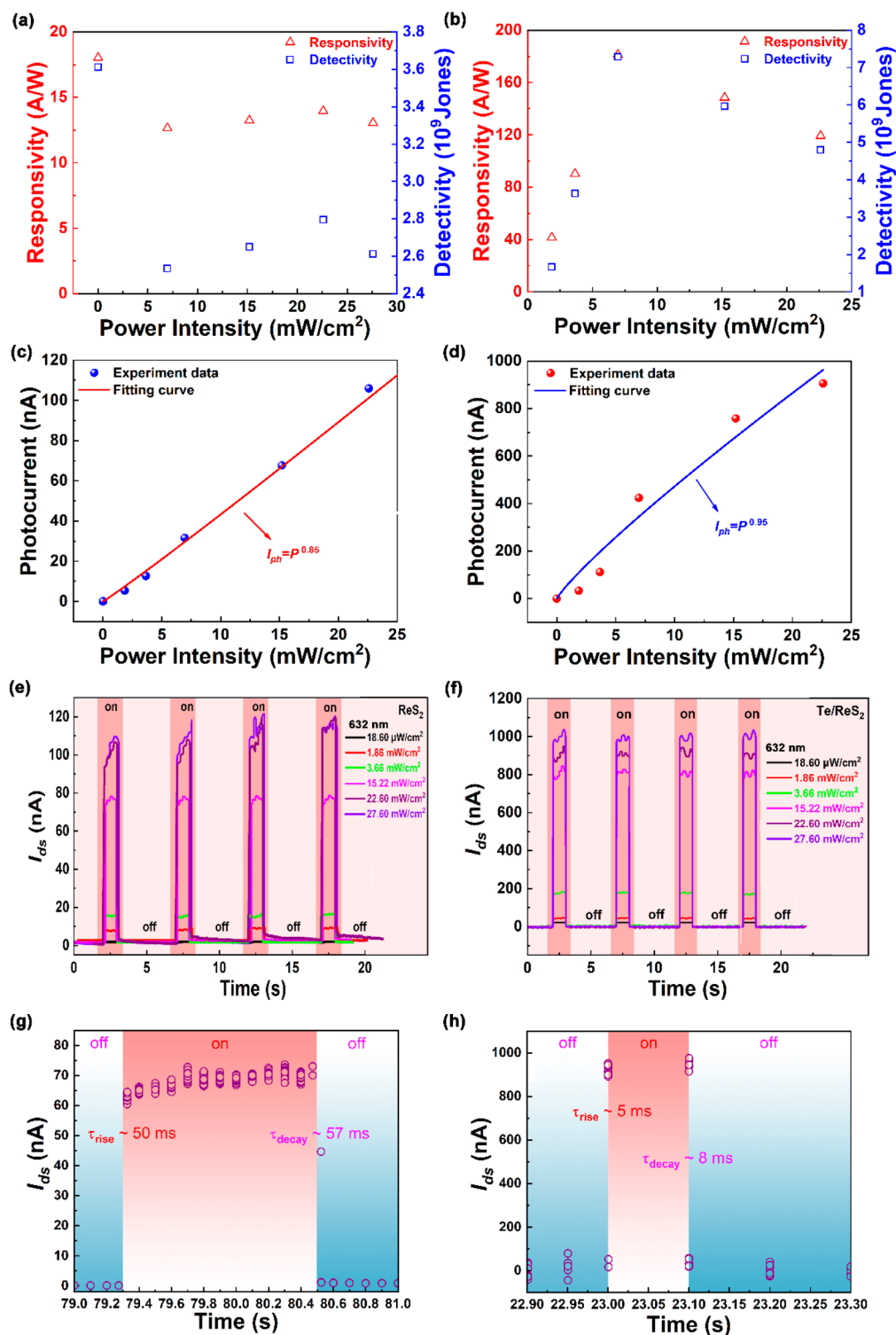
there is a lack of research on the photoelectric detection technology combining 2D materials with 1D Te nanowires (NWs). Further, the unclear interaction mechanism of 2D materials and 1D Te in the vdW heterojunctions hamper prospects in optoelectronic applications.

This study demonstrates a mixed-dimensional vdW heterojunction of 1D *p*-type Te NW and 2D *n*-type ReS<sub>2</sub> nanoflake (NF) for photoelectric detection applications. The Te NWs were first prepared by a facile hydrothermal method and then transferred to the ReS<sub>2</sub> NFs layer using the dry transfer method. Subsequently, this study evaluated, in the context to the photodetector performance, the electrical properties of the proposed dual-channel field-effect transistors (FETs). Compared to 2D ReS<sub>2</sub> NF, the 1D Te/2D ReS<sub>2</sub> heterojunction shows a significant improvement in light absorption, an increase in the electron–hole pair concentration, and the improved injection and separation efficiency of electron–hole pairs at the interface. This significant improvement is due to the light trapping effect, type II band alignment, and built-in electric field in the constructed Te/ReS<sub>2</sub> heterojunction. The photoresponsivity and photoresponse rate of the Te/ReS<sub>2</sub> heterojunction photodetector are superior to the bare Te or ReS<sub>2</sub> devices. Therefore, the 1D Te/2D ReS<sub>2</sub> heterojunction is a valuable addition to the array of mixed-

dimensional *p*–*n* heterojunction, which has widened the scope of the implementation in optoelectronics and sensor applications.

## RESULTS AND DISCUSSION

**Material Characterization.** Figure 1a depicts the SEM image of the synthesized Te sample. The Te NWs with a length of more than 10  $\mu$ m appear uniformly on the silicon substrate. Besides, as depicted in the set of Figure 1a, the diameter of Te NW is about 70 nm. The calculated aspect ratio of Te is 200, which indicates the anisotropy of Te NWs, and the smooth surface of Te NWs indicates high purity and quality. Figure 1b demonstrates the optical images of ReS<sub>2</sub> NFs, the as-grown Te NWs, and Te/ReS<sub>2</sub> heterojunction. Part (i) depicts the different thicknesses of ReS<sub>2</sub> NFs distinguishable by the optical contrast. Part (ii) depicts the easy separation of single Te NW and multiple NWs, which are the conditions for successful transfer and device fabrication. A single nanowire with a thicker diameter is formed by clustering multiple single nanowires. Part (iii) depicts the single Te NW with a thicker diameter that is tightly attached to ReS<sub>2</sub> NF, forming a Te/ReS<sub>2</sub> heterojunction. Figure 1c and its insets show the measured corresponding thickness and AFM image of ReS<sub>2</sub>, respectively. The thickness of ReS<sub>2</sub> NFs for the



**Figure 3.** Optoelectronic performance characterization of the ReS<sub>2</sub> and Te/ReS<sub>2</sub> photodetectors. (a, b) Responsivity and detectivity and (c, d) experimental and fitted photocurrent of devices as a function of the illumination intensity. (e, f) Time-dependent photocurrent response under switched-on/off light irradiation with different power intensities at  $V_d$  of 9 and 2 V and  $V_g$  of  $-55$  and 0 V for ReS<sub>2</sub> and Te/ReS<sub>2</sub>, respectively. (g, h) Temporal illumination response of the single on/off cycle highlights  $\tau_{\text{rise}}$  and  $\tau_{\text{decay}}$  time under an illumination intensity of 15.22 mW/cm<sup>2</sup>.

fabrication of devices is estimated to be 7.80 nm, which is appropriate as per the previously reported best optoelectronic performance.<sup>37</sup> Besides, no air bubbles in the overlapping heterojunction region indicate a strongly coupled Te and ReS<sub>2</sub> interface.

Figure 1d depicts the Raman spectra of Te, ReS<sub>2</sub>, and Te/ReS<sub>2</sub> heterojunction. Specifically, for pristine Te (blue color spectrum), the three peaks at 92, 120, and 140 cm<sup>-1</sup> are the respective characteristic peaks of the E<sub>1</sub>, A<sub>1</sub>, and E<sub>2</sub> modes, as per the previous results.<sup>38</sup> For pristine ReS<sub>2</sub> (red color

spectrum), the three Raman peaks at 160, 308, and 211  $\text{cm}^{-1}$  correspond to the  $E_g$  modes (in-plane vibration) and  $A_{1g}$  mode (out of plane vibration), respectively. These peak positions are as per the reported Raman results of  $\text{ReS}_2$ .<sup>39</sup> All the peaks of Te and  $\text{ReS}_2$  presented in the constructed Te/ $\text{ReS}_2$  interface indicate the formation of a Te/ $\text{ReS}_2$  heterojunction. However, compared to the Raman peaks in pristine  $\text{ReS}_2$ , minor blue shifts are observed in the Raman peaks in Te/ $\text{ReS}_2$  due to the vdW interaction between top Te NW and bottom  $\text{ReS}_2$  NF.<sup>40</sup> No apparent peak-shifts in the Raman peak positions of Te unveil the high-quality monolayer Te after fabrication of the vdW heterojunction. Diffraction peaks in Figure 1e validate the presence of triclinic phase  $\text{ReS}_2$  (PDF no. 89-1379).<sup>41</sup> Figure 1f shows the XRD patterns of Te NWs, with the diffraction peaks as per the hexagonal Te (PDF no. 36-1542).<sup>42</sup> Besides, a lack of other impurity peaks establishes the superior crystallinity and purity of the as-grown Te NWs and  $\text{ReS}_2$  NFs.

Figure S1 schematically illustrates the fabrication process of the Te/ $\text{ReS}_2$  heterojunction photodetector. In addition, the experimental methods of the Supporting Information detail the process. First, the use of the two-step dry transfer provides the integrated Te/ $\text{ReS}_2$  heterojunction. This method also establishes an intimate bonding between Te NW and  $\text{ReS}_2$  NF. The vertical device structures obtained have four levels,  $\text{ReS}_2$ -on- $\text{SiO}_2/p^+$ -Si substrate, Te NF, and top Au/Cr electrodes. Subsequently, for the systematic comparison, the individual Te and  $\text{ReS}_2$  PDs are also fabricated. Figure S2 depicts the SEM and optical microscope images of all devices.

Figure S3 depicts the  $I_{\text{ds}}-V_{\text{d}}$  curves at  $V_{\text{g}}$  of 0 V investigating the contact behaviors of FETs. The contacts at source/drain demonstrate Schottky behaviors of the Te NWs device at room temperature, while the  $\text{ReS}_2$ - and Te/ $\text{ReS}_2$ -based FETs demonstrate typical Ohmic behaviors. Parts a and b of Figure 2 depict the schematic structures of the devices. Parts c and d of Figure 2 show the transfer characteristics ( $I_{\text{ds}}-V_{\text{g}}$ ) on linear and semilogarithmic scales of  $\text{ReS}_2$  and Te/ $\text{ReS}_2$  FETs at the  $V_{\text{ds}} = 1$  V in the dark. As depicted in Figure 2c, the  $\text{ReS}_2$ -based FET showed excellent  $n$ -type behaviors with a high on/off ratio ( $\sim 10^7$ ) and a low off-state current ( $10^{-13}$  A). The observed threshold voltage ( $V_{\text{th}}$ ) of nearly  $-30$  V suggests large electron concentration or natural  $n$ -doping for  $\text{ReS}_2$  device, which results from S vacancies or impurities of  $\text{ReS}_2$  NFs.<sup>43</sup> Conversely, as depicted in Figure 2d, the Te/ $\text{ReS}_2$  FETs show a poor on/off ratio ( $\sim 20$ ) and high off-state current ( $10^{-8}$  A). As compared to the  $\text{ReS}_2$  FETs,  $V_{\text{th}}$  for Te/ $\text{ReS}_2$  FETs shows a red shift from  $-30$  to  $-20$  V. At  $V_{\text{g}} = 60$  V and  $V_{\text{ds}} = 1$  V, compared to  $\text{ReS}_2$  FETs, the on-state current of Te/ $\text{ReS}_2$  FETs presents an order of magnitude decrease, which could significantly reduce the testing noise and enhance the detectivity of photodetectors. Such electrical behavior changes indicate that the hole carriers of  $p$ -type of Te flakes dominate the transport properties of Te/ $\text{ReS}_2$  FETs, which attributes to the distinct  $p$ -doping effect of vertical stacked 1D Te NWs on the underlying 2D  $\text{ReS}_2$  NFs. In addition, the transfer characteristic of Te was demonstrated in Figure S4 and a conspicuous  $p$ -type behavior was observed, which shows poor performance with low on/off ratio of about 10. The following relation provided the field-effect carrier mobility ( $\mu$ ):

$$\mu = \frac{L}{W} \left( \frac{dI_{\text{ds}}}{dV_{\text{g}}} \right) \frac{1}{C_{\text{g}} V_{\text{ds}}} \quad (1)$$

Among them,  $L$ ,  $W$ ,  $(dI_{\text{ds}}/dV_{\text{g}})$ , and  $C_{\text{g}}$  are the channel length, channel width, slope of the transfer characteristics, and gate capacitance of the Si/ $\text{SiO}_2$  substrate, respectively. Mobility for  $\text{ReS}_2$  and Te/ $\text{ReS}_2$  FETs was 18 and 5  $\text{cm}^2/(\text{V s})$ , respectively. The mobility of Te/ $\text{ReS}_2$  FETs was much lower than that of  $\text{ReS}_2$  FETs, similar to the previously reported values for other  $\text{ReS}_2$ -based FETs.<sup>26</sup>

The laser diodes, as the light source, operating at a wavelength of 632 nm with different optical power densities ( $P_{\text{in}}$ ), investigated the optoelectronic properties of Te,  $\text{ReS}_2$ , and Te/ $\text{ReS}_2$  FETs. Figure S5 presents the  $V_{\text{g}}-I_{\text{ds}}$  characteristics of  $\text{ReS}_2$  and Te/ $\text{ReS}_2$  devices at different light intensities. It shows that maximum change values in  $I_{\text{ds}}$  before and after illumination occur at a  $V_{\text{g}}$  of  $-55$  and 0 V for  $\text{ReS}_2$  and Te/ $\text{ReS}_2$  FETs, respectively. Figure S6 depicts optoelectronic properties of the Te NWs device, exhibiting a nonobvious response under 22.6  $\text{mW}\cdot\text{cm}^{-2}$  illumination. Subsequently, parts e and f of Figure 2 show the  $I_{\text{ds}}-V_{\text{d}}$  curves of  $\text{ReS}_2$  and Te/ $\text{ReS}_2$  devices under different optical power densities ( $P_{\text{in}}$ ) of illumination and dark, respectively. It revealed that the dark current ( $I_{\text{dark}}$ ) did not change much with increasing  $V_{\text{ds}}$  under no light illumination for all devices. At  $V_{\text{ds}} = 9$  V, the  $I_{\text{dark}}$  was only 0.26 pA for  $\text{ReS}_2$  FETs and 65.02 nA for Te/ $\text{ReS}_2$  at  $V_{\text{ds}} = 0$  V. Thus, all devices depicted a distinct photoresponse, where  $I_{\text{ds}}$  gradually increases with an increase in  $P_{\text{in}}$  from 1.86 to 22.6  $\text{mW}/\text{cm}^2$ . As compared to the Te device, Te/ $\text{ReS}_2$  device had higher  $I_{\text{ds}}$  even at low  $P_{\text{in}}$  (1.86  $\text{mW}/\text{cm}^2$ ), indicating a highly sensitive photodetection for the visible range (632 nm).

For photodetectors, responsivity ( $R$ ) and detectivity ( $D$ ) are critical parameters represented by the following equations<sup>44</sup>

$$R = \frac{I_{\text{photo}} - I_{\text{dark}}}{P_{\text{in}} A} \quad (2)$$

where  $I_{\text{photo}}$  is the measured photocurrent,  $I_{\text{dark}}$  is the dark current, and  $P_{\text{in}}$  and  $A$  are the light illumination intensity and active area.

$$D = \frac{R}{(2qI_{\text{dark}}/A)^{1/2}} \quad (3)$$

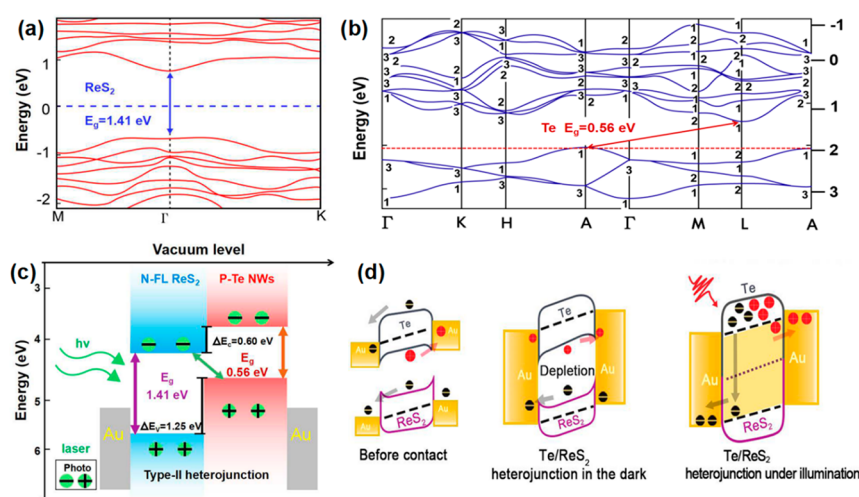
Among them,  $q$  represents the elementary charge. Parts a and b of Figure 3 show the calculated  $R$  and  $D$  under various incident power densities for  $\text{ReS}_2$  and Te/ $\text{ReS}_2$  heterojunction photodetectors. The maximum  $R$  and  $D$  of the  $\text{ReS}_2$  device are 20 A/W and  $3.6 \times 10^9$  Jones, respectively, at  $V_{\text{d}} = 1$  V, and  $V_{\text{g}} = -55$  V with the power density of 18.60  $\mu\text{W}/\text{cm}^2$ , which is higher than the other  $\text{ReS}_2$  photodetectors.<sup>7</sup> Further, at the  $V_{\text{d}} = 1$  V and power density of 18.60  $\mu\text{W}/\text{cm}^2$ ,  $R$  of the Te/ $\text{ReS}_2$  heterojunction photodetector was 180 A/W, which was one order higher than that of  $\text{ReS}_2$  photodetector. Besides, the  $D$  of the Te/ $\text{ReS}_2$  photodetector is  $7.2 \times 10^9$  Jones, which promoted by two times compared to  $\text{ReS}_2$  photodetector. The  $D$  is influenced by the defects of  $\text{ReS}_2$  from S vacancies in Te/ $\text{ReS}_2$  heterojunction, which leads the high dark current. Nonetheless, the  $10^9$  Jones of  $D$  is comparable with other reported composite structures.<sup>45,46</sup> For the device defects verification, the incident light intensity-dependent photocurrent curves are as per the following power law<sup>47</sup>

$$I \propto P^\theta \quad (4)$$

where  $I$  is the photocurrent,  $P$  is the light intensity, and  $\theta$  is the power exponent. As depicted in Figure 3c,d, the power exponent ( $\theta$ ) is 0.85 and 0.95 for  $\text{ReS}_2$  and Te/ $\text{ReS}_2$

**Table 1. Performance Parameters Comparison of Photodetectors based on 1D Te NWs and 2D ReS<sub>2</sub> NFs with Other Mixed-Dimensional Heterojunction Photodetectors Reported in the Literature**

photodetector	wavelength (nm)	responsivity (A/W)	detectivity (Jones)	rise time (s)	decay time (s)	refs
2D ReS <sub>2</sub> nanoflakes	220	13		6	21	11
1D ReS <sub>2</sub> nanowires	500	$5.08 \times 10^5$	$6.1 \times 10^{15}$	1.8	3.9	14
2D Te nanosheets	261	$6.5 \times 10^4$	$3.73 \times 10^8$	2	5	52
1D/2D Se/InSe	460	32	$1.7 \times 10^{11}$	0.030	0.037	25
1D/2D t-Se/ReS <sub>2</sub>	400	98	$6 \times 10^{10}$	0.05	0.05	26
1D/1D Te/TiO <sub>2</sub>	350	0.084	$3.7 \times 10^9$	0.772	1.492	53
1D/2D Se/ReS <sub>2</sub>	370	36	$8 \times 10^{12}$	0.01	0.01	45
1D/2D Sb <sub>2</sub> Se <sub>3</sub> /WS <sub>2</sub>	520	1.51	$1.16 \times 10^{10}$	0.008	0.008	50
2D/2D CdS/MoS <sub>2</sub>	610	3.91		0.01	0.01	54
1D/1D ZnO/Co <sub>3</sub> O <sub>4</sub>	solar light	21.80	$4.12 \times 10^{12}$	6	6	55
2D ReS <sub>2</sub> nanoflakes	632	20	$3.6 \times 10^{11}$	0.05	0.057	this work
1D/2D Te/ReS <sub>2</sub>	632	180	$5 \times 10^9$	0.005	0.008	this work

**Figure 4. Electronic band structures of (a) ReS<sub>2</sub>, and (b) Te. (c) Band alignment of the Te/ReS<sub>2</sub> heterojunction. (d) Energy band diagram and carrier transport of the Te and ReS<sub>2</sub> for before contact, after contact, and under light irradiation. The Fermi energy is set as zero energy.**

heterojunction, respectively. For the ReS<sub>2</sub> photodetector, the sublinear response curve with light intensity indicates that the photogenerated carrier recombination due to intrinsic defects or the charge impurities at the surface of the ReS<sub>2</sub>.<sup>48</sup> Moreover, the calculated  $\theta$  of Te/ReS<sub>2</sub> is higher than ReS<sub>2</sub>, which suggests the fewer recombination centers exist in the heterojunction. These results are dependent on the charge impurities around the ReS<sub>2</sub> with reduced after Te covering compared to intrinsic ReS<sub>2</sub>. Besides, the part of the surface of ReS<sub>2</sub>, previously occupied by O<sub>2</sub>/H<sub>2</sub>O, was drastically covered by the Te/ReS<sub>2</sub> interfaces due to surface recombination sites.<sup>49</sup> A similar sublinear dependence in Se/InSe and Sb<sub>2</sub>Se<sub>3</sub>/WS<sub>2</sub> vertical bilayer heterostructures have been previously reported.<sup>25,50</sup>

The response speed includes the on/off current ratio, and the rise and decay time is another vital parameter for photodetector. This study further assessed the time dependence of photocurrent with the laser turning on or off for demonstrating the device response speed. As depicted in Figure 3e,f, upon illumination, the device current generated increases sharply, then stabilizes in a higher current, and finally vanishes in the dark, which is steady and reproducible over the repeated cycles, exhibiting excellent stability and reliability of all devices. Moreover, the photoswitching on/off ratio of Te/ReS<sub>2</sub> (1000) is significantly higher than that the ReS<sub>2</sub> device (200), which is similar to the  $V_d - I_{ds}$  results demonstrated in

Figure 2e,f. The time taken by the pulse amplitude to rise from 10% to 90% of the maximum value and vice versa is the rise and decay time of devices. Further, the on/off current ratio and the rise and decay times of device were characterized and depicted in Figure 3g,h. For ReS<sub>2</sub>, the rise and decay times were nearly 50 and 57 ms, respectively. The rise and decay times for the Te/ReS<sub>2</sub> device under illumination was equal or less than 5 and 8 ms, which was beyond the measurement capability of the equipment used. Compared to the bare ReS<sub>2</sub> photodetector, seven to ten times faster rising and decaying time was exhibited by the Te/ReS<sub>2</sub> heterojunction photodetector. This excellent performance can be due to the Te NWs acting as the absorption layer and the built-in electric field inducement, aiding in efficient photocarrier extraction from the Te/ReS<sub>2</sub> heterojunction.<sup>51</sup> Optoelectronic performance parameters comparison of Te/ReS<sub>2</sub> photodetector with other mixed-dimensional visible heterojunction photodetectors reported in the literature demonstrated similarity and improvement (Table 1). It suggests a promising application of the proposed Te/ReS<sub>2</sub> for highly efficient visible photodetection.

The electronic band structures of ReS<sub>2</sub> and Te calculated by density functional theory are shown in Figure 4a,b. The calculation details are provided in Supporting Information. From the calculated results, the ReS<sub>2</sub> has a direct band gap of 1.41 eV, corresponding to the other reported result.<sup>56</sup> For Te, the results display the band gap of 0.56 eV, which is in accord

with the reported value.<sup>57</sup> As shown in Figure 4c, both the conduction band maximum (CBM) and valence band minimum (VBM) of Te are higher than that of ReS<sub>2</sub>. Thus, the Te/ReS<sub>2</sub> heterojunction have a type II band alignment. Figure 4d demonstrates the photocarriers transmission of Te/ReS<sub>2</sub> heterojunction under dark and light. Under dark conditions, Au, ReS<sub>2</sub>, and Te have different Fermi energies formation before contact with each other. The contact of ReS<sub>2</sub> and Te with Au forms the low Schottky barriers at the interfaces. The charge transfer and electron–hole recombination occurred at the Te/ReS<sub>2</sub> interface during the Te/ReS<sub>2</sub> heterojunction formation. This behavior of charge transmission lowers/raises the Fermi level of ReS<sub>2</sub> (Te), causing the formation of depletion regions and introducing a built-in field toward ReS<sub>2</sub>. The depletion region formation accompanied by the Schottky barrier reduction at the Au/ReS<sub>2</sub> (Au/Te) interfaces significantly suppresses the dark current in the heterojunction bilayers.<sup>58</sup> The light illumination causes the generation of electron–hole pairs in the Te NWs; thereby the electrons are transferred to ReS<sub>2</sub> NFs, and photoexcited holes in ReS<sub>2</sub> NFs transfer to Te NWs. The charge separation is beneficial in reducing electrons and holes recombination, which enhancing the photogenerated current. This phenomenon raises the Fermi level in ReS<sub>2</sub> NFs while lowers that of Te NWs. The accumulated electrons (holes) in ReS<sub>2</sub> NFs (Te NWs) could transport through the two channels driven applied electric field of  $V_{ds}$  and be captured immediately by the electrodes, resulting in a high photocurrent.

Meanwhile, the reduced Schottky barriers at the contact interfaces (Au/ReS<sub>2</sub> and Au/Te) account by modulation of Fermi level also facilitate the carrier injection and enhances the channel current.<sup>59</sup> The ReS<sub>2</sub> can bond with gas molecules for the high chemical activity of Re atom. As a result, the trap states in the band gap generate that will a poor photoresponse speed.<sup>60</sup> The introduction of Te NWs enhances the absorption of light and causes surface defects of ReS<sub>2</sub>, which significantly increases the photocurrent. Furthermore, the Re–Te bond at the interface provides a direct path for carrier separation and transfer, which accelerated the response speed.<sup>61</sup>

## CONCLUSIONS

In summary, this study proposes a fabricated 1D Te/2D ReS<sub>2</sub> mixed-dimensional van der Waals *p–n* heterojunction using hydrothermal, mechanical exfoliation, and dry transfer methods. This study had explored the electronic and optoelectronic properties of Te NWs, ReS<sub>2</sub> NFs, and their heterojunction devices. Compared to the pristine Te and ReS<sub>2</sub> photodetectors, the Te/ReS<sub>2</sub> heterojunction photodetector has superior performance with excellent responsivity (180 A/W), high specific detectivity ( $10^9$ ), and short photoresponse time (5 ms). The responsivity and response time are higher by 1 order of magnitude than the ReS<sub>2</sub>-alone device. These improvements are due to the benefits from the type-II band alignments, enhanced light absorption, and passivate surface effect of heterojunction, which also rapidly separates the photogenerated electron–hole pairs. The performance improvements reported in this study can provide a fabrication method of mixed-dimensional van der Waals heterojunction for optoelectronic applications.

## EXPERIMENTAL SECTION

**Growth of 1D Te NWs.** To construct 1D Te/2D ReS<sub>2</sub> mixed-dimensional heterojunction, first the Te NWs were synthesized by the

hydrothermal method as previously reported.<sup>53</sup> This process provides Te NWs of controlled diameters and lengths. All the chemicals in the experiment were weighed using a METTLER TOLEDO ME 204 balance. Furthermore, Te NWs synthesized by the hydrothermal method have demonstrated excellent optical and electrical properties, which show potential for photodetector application.<sup>62,35</sup>

**Fabrication of the Heterojunction Photodetectors.** First is the alcohol dispersion of the as-prepared Te NWs, and next is the coating on a SiO<sub>2</sub> (280 nm)/p<sup>+</sup>-Si wafer by a spin-coating method for transfer process. Simultaneous is the mechanical exfoliation of ReS<sub>2</sub> NFs from a ReS<sub>2</sub> bulk (Six Carbon Technology Supplies) onto the SiO<sub>2</sub> (280 nm)/p<sup>+</sup>-Si substrate with a scotch-tape method. The ReS<sub>2</sub> NFs of 7–8 nm thickness on the proper lateral size of the substrate was selected for the heterojunction fabrication. Later, Te NWs transferred onto the ReS<sub>2</sub>/Si substrate by a dry transfer method with the help of accurate transfer platform (Metatest, E1-T), from the 1D Te/2D ReS<sub>2</sub> mixed-dimensional heterojunction. For the fabrication of Te, ReS<sub>2</sub>, and Te/ReS<sub>2</sub> devices, source-drain electrodes were defined by the electron beam lithography and followed by the deposition of Cr/Au with 10/70 nm deposited by physical vapor deposition equipment, followed by a lift-off process in acetone.

**Characterizations and Measurements of Photodetectors.** An X-ray diffractometer (Bruker, D8) was used to determine the crystalline structure of samples. Raman spectroscopy (Lab RAM HR800, Horiba Jobin Yvon) with an excitation wavelength of 532 nm analyzed the optical properties. The thickness and surface morphology of samples were measured by AFM (Dimension Icon, Bruker) in tapping mode and SEM (Sigma HD, Zeiss), respectively. The electrical performance measurement was by a semiconductor parameter analyzer (Keysight, B1500) in a robe station (Lake Shore). For photodetector performance measurements, a light source of 632 nm laser diode (Thorlabs, LD632P70MLD) evaluated the photoresponse. The laser first passes through the collimator to obtain a parallel beam, which then shines onto the device channel. The laser switch controlling is by the laser controller (Thorlabs, LDC4001), which can achieve photoresponse speed measurement. The signal was amplified through a lock-in amplifier (Stanford, SR570) and then detected by a digital oscilloscope.

## ASSOCIATED CONTENT

### Supporting Information

The Supporting Information is available free of charge at <https://pubs.acs.org/doi/10.1021/acsnano.0c09912>.

Experimental methods, schematic for the fabrication process of Te, ReS<sub>2</sub>, and Te/ReS<sub>2</sub> FET based phototransistors, SEM and optical microscope images of ReS<sub>2</sub> and Te/ReS<sub>2</sub> devices,  $I_{ds}$ – $V_d$  curves at  $V_g$  of 0 V of Te, ReS<sub>2</sub>, and Te/ReS<sub>2</sub> devices, transfer curve of Te FET measured under dark at  $V_{ds} = 1$  V,  $V_g$ – $I_{ds}$  characteristics of ReS<sub>2</sub> and Te/ReS<sub>2</sub> devices at different light intensity with the wavelength of 632 nm, and  $I_d$ – $V_d$  of pure Te device under dark conditions and at maximum light intensity of 22.6 mW/cm<sup>2</sup> with the wavelength of 632 nm (PDF)

## AUTHOR INFORMATION

### Corresponding Authors

Young Hee Lee – Center for Integrated Nanostructure Physics (CINAP), Institute for Basic Science (IBS), Department of Energy Science, Department of Physics, Sungkyunkwan University, Suwon 16419, Republic of Korea; [orcid.org/0000-0001-7403-8157](https://orcid.org/0000-0001-7403-8157); Email: [leeyoung@skku.edu](mailto:leeyoung@skku.edu)

Hong-Liang Lu – State Key Laboratory of ASIC and System, Shanghai Institute of Intelligent Electronics & Systems, School of Microelectronics, Fudan University, Shanghai 200433,

China; [orcid.org/0000-0003-2398-720X](https://orcid.org/0000-0003-2398-720X);  
Email: honglianglu@fudan.edu.cn

## Authors

**Jia-Jia Tao** – State Key Laboratory of ASIC and System, Shanghai Institute of Intelligent Electronics & Systems, School of Microelectronics, Fudan University, Shanghai 200433, China

**Jinbao Jiang** – Center for Integrated Nanostructure Physics (CINAP), Institute for Basic Science (IBS), Department of Energy Science, Department of Physics, Sungkyunkwan University, Suwon 16419, Republic of Korea

**Shi-Nuan Zhao** – Collaborative Innovation Center of Advanced Microstructures, State Key Laboratory of Applied Surface Physics, Department of Physics, Fudan University, Shanghai 200433, China

**Yong Zhang** – Department of Materials Science, Fudan University, Shanghai 200433, China

**Xiao-Xi Li** – State Key Laboratory of ASIC and System, Shanghai Institute of Intelligent Electronics & Systems, School of Microelectronics, Fudan University, Shanghai 200433, China

**Xiaosheng Fang** – Department of Materials Science, Fudan University, Shanghai 200433, China; [orcid.org/0000-0003-3387-4532](https://orcid.org/0000-0003-3387-4532)

**Peng Wang** – State Key Laboratory of Infrared Physics, Shanghai Institute of Technical Physics Chinese Academy of Sciences, Shanghai 200083, China

**Weida Hu** – State Key Laboratory of Infrared Physics, Shanghai Institute of Technical Physics Chinese Academy of Sciences, Shanghai 200083, China; [orcid.org/0000-0001-5278-8969](https://orcid.org/0000-0001-5278-8969)

**David-Wei Zhang** – State Key Laboratory of ASIC and System, Shanghai Institute of Intelligent Electronics & Systems, School of Microelectronics, Fudan University, Shanghai 200433, China

Complete contact information is available at:  
<https://pubs.acs.org/10.1021/acsnano.0c09912>

## Author Contributions

J.T., J.J., and Y.Z. designed the research. S.Z. and X.L. performed the XRD and Raman measurements. X.F. and P.W. contributed to device fabrication. W.H., Y.L., L.L., and D.Z. assisted with data analysis. J.T. wrote the paper, and all authors commented on the manuscript.

## Notes

The authors declare no competing financial interest.

## ACKNOWLEDGMENTS

This work is supported by the National Natural Science Foundation of China (Nos. 61874034, 51861135105, and U1632121) and the Natural Science Foundation of Shanghai (No. 18ZR1405000). This work is also supported by the Fudan University Exchange Program Scholarship for Doctoral Students (No. 2019026). The authors thank Prof. Yi-Fang Chen, Fudan University, for the scanning electron microscopy tests.

## REFERENCES

(1) Dai, M. J.; Chen, H. Y.; Feng, R.; Feng, W.; Hu, Y. X.; Yang, H. H.; Liu, G. B.; Chen, X. S.; Zhang, J.; Xu, C. Y.; Hu, P. A. A Dual-Band Multilayer InSe Self-Powered Photodetector with High

Performance Induced by Surface Plasmon Resonance and Asymmetric Schottky Junction. *ACS Nano* **2018**, *12*, 8739–8747.

(2) Dai, M. J.; Zheng, W.; Zhang, X.; Wang, S. M.; Lin, J. H.; Li, K.; Hu, Y. X.; Sun, E. W.; Zhang, J.; Qiu, Y. F.; Fu, Y. Q.; Cao, W. W.; Hu, P. A. Enhanced Piezoelectric Effect Derived from Grain Boundary in MoS<sub>2</sub> Monolayers. *Nano Lett.* **2020**, *20*, 201–207.

(3) Hu, P. A.; Wang, L. F.; Yoon, M.; Zhang, J.; Feng, W.; Wang, X. N.; Wen, Z. Z.; Idrobo, J. C.; Miyamoto, Y.; Gehegan, D. B.; Xiao, K. Highly Responsive Ultrathin GaS Nanosheet Photodetectors on Rigid and Flexible Substrates. *Nano Lett.* **2013**, *13*, 1649–1654.

(4) Yu, M. M.; Hu, Y. X.; Gao, F.; Dai, M. J.; Wang, L. F.; Hu, P. A.; Feng, W. High-Performance Devices Based on InSe-In<sub>1-x</sub>Ga<sub>x</sub>Se Van der Waals Heterojunctions. *ACS Appl. Mater. Interfaces* **2020**, *12*, 24978–24983.

(5) Dai, M. J.; Chen, H. Y.; Wang, F. K.; Hu, Y. X.; Wei, S.; Zhang, J.; Wang, Z. G.; Zhai, T. Y.; Hu, P. A. Robust Piezo-Phototronic Effect in Multilayer  $\gamma$ -InSe for High-Performance Self-Powered Flexible Photodetectors. *ACS Nano* **2019**, *13*, 7291–7299.

(6) Hu, P. A.; Wen, Z. Z.; Wang, L. F.; Tan, P. H.; Xiao, K. Synthesis of Few-Layer GaSe Nanosheets for High Performance Photodetectors. *ACS Nano* **2012**, *6*, 5988–5994.

(7) Dai, M. J.; Wang, Z. G.; Wang, F. K.; Qiu, Y. F.; Zhang, J.; Xu, C. Y.; Zhai, T. Y.; Cao, W. W.; Fu, Y. Q.; Jia, D. C.; Zhou, Y.; Hu, P. A. Two-Dimensional van der Waals Materials with Aligned In-Plane Polarization and Large Piezoelectric Effect for Self-Powered Piezoelectric Sensors. *Nano Lett.* **2019**, *19*, 5410–5416.

(8) Dai, M. J.; Zheng, W.; Zhang, X.; Wang, S. M.; Lin, J. H.; Li, K.; Hu, Y. X.; Sun, E. W.; Zhang, J.; Qiu, Y. F.; Fu, Y. Q.; Cao, W. W.; Hu, P. A. Enhanced Piezoelectric Effect Derived from Grain Boundary in MoS<sub>2</sub> Monolayers. *Nano Lett.* **2020**, *20*, 201–207.

(9) Thakar, K.; Mukherjee, B.; Grover, S.; Kaushik, N.; Deshmukh, M.; Lodha, S. Multilayer ReS<sub>2</sub> Photodetectors with Gate Tunability for High Responsivity and High-Speed Applications. *ACS Appl. Mater. Interfaces* **2018**, *10*, 36512–36522.

(10) Zhao, K. Y.; Huang, F. M.; Dai, C. M.; Li, W. W.; Chen, S. Y.; Jiang, K.; Huang, Y. P.; Hu, Z. G.; Chu, J. H. Temperature Dependence of Phonon Modes, Optical Constants, and Optical Band Gap in Two-Dimensional ReS<sub>2</sub> Films. *J. Phys. Chem. C* **2018**, *122*, 29464–29469.

(11) Nazir, G.; Rehman, M. A.; Khan, M. F.; Dastgeer, G.; Aftab, S.; Afzal, A. M.; Seo, Y.; Eom, J. Comparison of Electrical and Photoelectrical Properties of ReS<sub>2</sub> Field-Effect Transistors on Different Dielectric Substrates. *ACS Appl. Mater. Interfaces* **2018**, *10*, 32501–32509.

(12) Xiang, D.; Liu, T.; Wang, J. Y.; Wang, P.; Wang, L.; Zheng, Y.; Wang, Y. N.; Gao, J.; Ang, K. W.; Eda, G.; Hu, W. D.; Liu, L.; Chen, W. Anomalous Broadband Spectrum Photodetection in 2D Rhenium Disulfide Transistor. *Adv. Opt. Mater.* **2019**, *7*, 1901115.

(13) Zhang, E.; Jin, Y. B.; Yuan, X.; Wang, W. Y.; Zhang, C.; Tang, L.; Liu, S. S.; Zhou, P.; Hu, W. D.; Xiu, F. X. ReS<sub>2</sub>-Based Field-Effect Transistors and Photodetectors. *Adv. Funct. Mater.* **2015**, *25*, 4076–4082.

(14) An, Q. W.; Liu, Y.; Jiang, R. J.; Meng, X. Q. Chemical Vapor Deposition Growth of ReS<sub>2</sub> Nanowires for High-Performance Nanostructured Photodetector. *Nanoscale* **2018**, *10*, 14976–14983.

(15) Lim, J.; Jeon, D.; Lee, S.; Yu, J. S.; Lee, S. Nucleation Promoted Synthesis of Large-Area ReS<sub>2</sub> Film for High-Speed Photodetectors. *Nanotechnology* **2020**, *31*, 115603.

(16) Xu, J.; Chen, L.; Dai, Y. W.; Cao, Q.; Sun, Q. Q.; Ding, S. J.; Zhu, H.; Zhang, D. W. A Two-Dimensional Semiconductor Transistor with Boosted Gate Control and Sensing Ability. *Sci. Adv.* **2017**, *3*, 1602246.

(17) Kannan, G.; Vasileska, D. The Impact of Surface-Roughness Scattering on the Low-Field Electron Mobility in Nano-Scale Si MOSFETs. *J. Appl. Phys.* **2017**, *122*, 114303.

(18) Liu, E. F.; Fu, Y. J.; Wang, Y. J.; Feng, Y. Q.; Liu, H. M.; Wan, X. G.; Zhou, W.; Wang, B. G.; Shao, L. B.; Ho, C. H.; Huang, Y. S.; Cao, Z. Y.; Wang, L. G.; Li, A. D.; Zeng, J. W.; Song, F. Q.; Wang, X. R.; Shi, Y.; Yuan, H. T.; Hwang, H. Y.; et al. Integrated Digital



Inverters Based on Two-Dimensional Anisotropic ReS<sub>2</sub> Field-Effect Transistors. *Nat. Commun.* **2015**, *6*, 6991.

(19) Ho, C. H.; Liao, P. C.; Huang, Y. S. Optical Absorption of ReS<sub>2</sub> and ReSe<sub>2</sub> Single Crystals. *J. Appl. Phys.* **1997**, *81*, 6380.

(20) Mukherjee, B.; Zulkefli, A.; Hayakawa, R.; Wakayama, Y.; Nakaharai, S. Enhanced Quantum Efficiency in Vertical Mixed-Thickness *n*-ReS<sub>2</sub>/*p*-Si Heterojunction Photodiodes. *ACS Photonics* **2019**, *6*, 2277–2286.

(21) Srivastava, P. K.; Hassan, Y.; Gebredingle, Y.; Jung, J.; Kang, B.; Yoo, W. J.; Singh, B.; Lee, C. van der Waals Broken-Gap *p*-*n* Heterojunction Tunnel Diode Based on Black Phosphorus and Rhenium Disulfide. *ACS Appl. Mater. Interfaces* **2019**, *11*, 8266–8275.

(22) Kang, B.; Kim, Y.; Yoo, W. J.; Lee, C. Ultrahigh Photoresponsive Device Based on ReS<sub>2</sub>/Graphene Heterostructure. *Small* **2018**, *14*, 1802593.

(23) Varghese, A.; Saha, D.; Thakar, K.; Jindal, V.; Ghosh, S.; Medhekar, N. V.; Ghosh, S.; Lodha, S. Near-Direct Bandgap WSe<sub>2</sub>/ReS<sub>2</sub> Type-II *p*-*n* Heterojunction for Enhanced Ultrafast Photodetection and High-Performance Photovoltaics. *Nano Lett.* **2020**, *20*, 1707–1717.

(24) Jariwala, D.; Marks, T. J.; Hersam, M. C. Mixed-Dimensional van der Waals Heterostructures. *Nat. Mater.* **2017**, *16*, 170–181.

(25) Shang, H. M.; Chen, H. Y.; Dai, M. J.; Hu, Y. X.; Gao, F.; Yang, H. H.; Xu, B.; Zhang, S. C.; Tan, B. Y.; Zhang, X.; Hu, P. A. A Mixed-Dimensional 1D Se-2D InSe van der Waals Heterojunction for High Responsivity Self-Powered Photodetectors. *Nanoscale Horiz.* **2020**, *5*, 564–572.

(26) Qin, J. K.; Yan, H.; Qiu, G.; Si, M. W.; Miao, P.; Duan, Y. Q.; Shao, W. Z.; Zhen, L.; Xu, C. Y.; Ye, P. D. Hybrid Dual-Channel Phototransistor Based on 1D t-Se and 2D ReS<sub>2</sub> Mixed-Dimensional Heterostructures. *Nano Res.* **2019**, *12*, 669–674.

(27) Wu, H. L.; Kang, Z.; Zhang, Z. H.; Si, H. N.; Liao, Q. L.; Zhang, S. C.; Wu, J.; Zhang, X. K.; Zhang, Y. Interfacial Charge Behavior Modulation in Perovskite Quantum Dot-Monolayer MoS<sub>2</sub> 0D-2D Mixed-Dimensional van der Waals Heterostructures. *Adv. Funct. Mater.* **2018**, *28*, 1802015.

(28) Choi, W.; Akhtar, I.; Kang, D.; Lee, Y. J.; Jung, J.; Kim, Y. H.; Lee, C. H.; Hwang, D. J.; Seo, Y. Optoelectronics of Multijunction Heterostructures of Transition Metal Dichalcogenides. *Nano Lett.* **2020**, *20*, 1934–1943.

(29) Peng, H.; Kioussis, N.; Snyder, G. J. Elemental Tellurium as a Chiral *p*-Type Thermoelectric Material. *Phys. Rev. B: Condens. Matter Mater. Phys.* **2014**, *89*, 195206.

(30) Wang, Q. S.; Safdar, M.; Xu, K.; Mirza, M.; Wang, Z. M.; He, J. van der Waals Epitaxy and Photoresponse of Hexagonal Tellurium Nanoplates on Flexible Mica Sheets. *ACS Nano* **2014**, *8*, 7497–7505.

(31) Lee, T.; Lee, S.; Lee, E.; Sohn, S.; Lee, Y.; Lee, S.; Moon, G.; Kim, D.; Kim, Y. S.; Myoung, J. M.; Wang, Z. L. High-Power Density Piezoelectric Energy Harvesting Using Radially Strained Ultrathin Trigonal Tellurium Nanowire Assembly. *Adv. Mater.* **2013**, *25*, 2920–2925.

(32) Qiu, G.; Huang, S. Y.; Segovia, M.; Venuthurumilli, P. K.; Wang, Y. X.; Wu, W. Z.; Xu, X. F.; Ye, P. D. Thermoelectric Performance of 2D Tellurium with Accumulation Contacts. *Nano Lett.* **2019**, *19*, 1955–1962.

(33) Pham, T.; Oh, S.; Stetz, P.; Onishi, S.; Kisielowski, C.; Cohen, M. L.; Zettl, A. Torsional Instability in the Single-Chain Limit of a Transition Metal Trichalcogenide. *Science* **2018**, *361*, 263–266.

(34) Shen, C. F.; Liu, Y. H.; Wu, J. B.; Xu, C.; Cui, D. Z.; Li, Z.; Liu, Q. Z.; Li, Y. R.; Wang, Y. X.; Cao, X.; Kumazoe, H.; Shimojo, F.; Krishnamoorthy, A.; Kalia, R. K.; Nakano, A.; Vashishta, P. D.; Amer, M. R.; Abbas, A. N.; Wang, H.; Wu, W. Z.; et al. Tellurene Photodetector with High Gain and Wide Bandwidth. *ACS Nano* **2020**, *14*, 303–310.

(35) Amani, M.; Tan, C. L.; Zhang, G.; Zhao, C. S.; Bullock, J.; Song, X. H.; Kim, H.; Shrestha, V. R.; Gao, Y.; Crozier, K. B.; Scott, M.; Javey, A. Solution-Synthesized High-Mobility Tellurium Nanoflakes for Short-Wave Infrared Photodetectors. *ACS Nano* **2018**, *12*, 7253–7263.

(36) Zhang, X.; Jiang, J. Z.; Suleiman, A. A.; Jin, B.; Hu, X. Z.; Zhou, X.; Zhai, T. Y. Hydrogen-Assisted Growth of Ultrathin Te Flakes with Giant Gate-Dependent Photoresponse. *Adv. Funct. Mater.* **2019**, *29*, 1906585.

(37) Thakar, K.; Mukherjee, B.; Grover, S.; Kaushik, N.; Deshmukh, M.; Lodha, S. Multilayer ReS<sub>2</sub> Photodetectors with Gate Tunability for High Responsivity and High-Speed Applications. *ACS Appl. Mater. Interfaces* **2018**, *10*, 36512–36522.

(38) Du, Y. C.; Qiu, G.; Wang, Y. X.; Si, M. W.; Xu, X. F.; Wu, W. Z.; Ye, P. D. One-Dimensional van der Waals Material Tellurium: Raman Spectroscopy under Strain and Magneto-Transport. *Nano Lett.* **2017**, *17*, 3965–3973.

(39) Miao, P.; Qin, J. K.; Shen, Y. F.; Su, H. M.; Dai, J. F.; Song, B.; Du, Y. C.; Sun, M. T.; Zhang, W.; Wang, H. L.; Xu, C. Y.; Xu, P. Unraveling the Raman Enhancement Mechanism on 1T-Phase ReS<sub>2</sub> Nanosheets. *Small* **2018**, *14*, 1704079.

(40) Zhao, M.; Zhang, W. T.; Liu, M. M.; Zou, C.; Yang, K. Q.; Yang, Y.; Dong, Y. Q.; Zhang, L. J.; Huang, S. M. Interlayer Coupling in Anisotropic/Isotropic van der Waals Heterostructures of ReS<sub>2</sub> and MoS<sub>2</sub> Monolayers. *Nano Res.* **2016**, *9*, 3772–3780.

(41) Brorson, M.; Hansen, T. W.; Jacobsen, C. J. H. Rhenium (IV) Sulfide Nanotubes. *J. Am. Chem. Soc.* **2002**, *124*, 11582–11583.

(42) Wang, H.; Tong, Z. Q.; Yang, R.; Huang, Z. M.; Shen, D.; Jiao, T. P.; Cui, X.; Zhang, W. J.; Jiang, Y.; Lee, C. S. Electrochemically Stable Sodium Metal-Tellurium/Carbon Nanorods Batteries. *Adv. Energy Mater.* **2019**, *9*, 1903046.

(43) Liu, E.; Long, M. S.; Zeng, J. W.; Luo, W.; Wang, Y. J.; Pan, Y. M.; Zou, W.; Wang, B. G.; Hu, W. D.; Ni, Z. H.; You, Y. M.; Zhang, X. A.; Qin, S. Q.; Shi, Y.; Watanabe, K.; Taniguchi, T.; Yuan, H. T.; Hwang, H. Y.; Cui, Y.; Miao, F.; Ding, X. High Responsivity Phototransistors Based on Few-Layer ReS<sub>2</sub> for Weak Signal Detection. *Adv. Funct. Mater.* **2016**, *26*, 1938–1944.

(44) Zhuo, R.; Zeng, L.; Yuan, H.; Wu, D.; Wang, Y.; Shi, Z.; Xu, T.; Tian, Y.; Li, X.; Tsang, Y. H. *In-Situ* Fabrication of PtSe<sub>2</sub>/GaN Heterojunction for Self-Powered Deep Ultraviolet Photodetector with Ultrahigh Current on/off Ratio and Detectivity. *Nano Res.* **2019**, *12*, 183–189.

(45) Qin, J. K.; Qiu, G.; He, W.; Jian, J.; Si, M. W.; Duan, Y. Q.; Charnas, A.; Zemlyanov, D. Y.; Wang, H. Y.; Shao, W. Z.; Zhen, L.; Xu, C. Y.; Ye, P. D. Epitaxial Growth of 1D Atomic Chain Based Se Nanoplates on Monolayer ReS<sub>2</sub> for High-Performance Photodetectors. *Adv. Funct. Mater.* **2018**, *28*, 1806254.

(46) Kufer, D.; Nikitskiy, I.; Lasanta, T.; Navickaite, G.; Koppens, F. H. L.; Konstantatos, G. Hybrid 2D-0D MoS<sub>2</sub>-PbS Quantum Dot Photodetectors. *Adv. Mater.* **2015**, *27*, 176–180.

(47) Sun, J. C.; Wang, Y. Y.; Guo, S. Q.; Wan, B. S.; Dong, L. Q.; Gu, Y. D.; Song, C.; Pan, C. F.; Zhang, Q. H.; Gu, L.; Pan, F.; Zhang, J. Y. Lateral 2D WSe<sub>2</sub> *p*-*n* Homo Junction Formed by Efficient Charge-Carrier-Type Modulation for High-Performance Optoelectronics. *Adv. Mater.* **2020**, *32*, 1906499.

(48) Mukherjee, B.; Zulkefli, A.; Hayakawa, R.; Wakayama, Y.; Nakaharai, S. Enhanced Quantum Efficiency in Vertical Mixed-Thickness *n*-ReS<sub>2</sub>/*p*-Si Heterojunction Photodiodes. *ACS Photonics* **2019**, *6*, 2277–2286.

(49) Zhou, N.; Wang, R. Y.; Zhou, X.; Song, H. Y.; Xiong, X.; Ding, Y.; Lü, J. T.; Gan, L.; Zhai, T. Y. *p*-GaSe/*n*-MoS<sub>2</sub> Vertical Heterostructures Synthesized by van der Waals Epitaxy for Photoresponse Modulation. *Small* **2018**, *14*, 1702731.

(50) Sun, G. Z.; Li, B.; Li, J.; Zhang, Z. W.; Ma, H. F.; Chen, P.; Zhao, B.; Wu, R. X.; Dang, W. Q.; Yang, X. D.; Tang, X. W.; Dai, C.; Huang, Z. W.; Liu, Y.; Duan, X. D.; Duan, X. F. Direct van der Waals Epitaxial Growth of 1D/2D Sb<sub>2</sub>Se<sub>3</sub>/WS<sub>2</sub> Mixed Dimensional *p*-*n* Heterojunctions. *Nano Res.* **2019**, *12*, 1139–1145.

(51) Ra, H. S.; Kwak, D. H.; Lee, J. S. A Hybrid MoS<sub>2</sub> Nanosheet-CdSe Nanocrystal Phototransistor with a Fast Photoresponse. *Nanoscale* **2016**, *8*, 17223–17230.

(52) Cao, R.; Zhang, Y.; Wang, H. D.; Zeng, Y. H.; Zhao, J. L.; Zhang, L. Y.; Li, J. Q.; Meng, F. X.; Shi, Z.; Fan, D. Y.; Guo, Z. N. Solar-Blind Deep-Ultraviolet Photodetectors Based on Solution-

Synthesized Quasi-2D Te Nanosheets. *Nanophotonics* **2020**, *9*, 2459–2466.

(53) Zhang, Y.; Xu, W. X.; Xu, X. J.; Yang, W.; Li, S. Y.; Chen, J. X.; Fang, X. S. Low-Cost Writing Method for Self-Powered Paper-Based UV Photodetectors Utilizing Te/TiO<sub>2</sub> and Te/ZnO Heterojunctions. *Nanoscale Horiz.* **2019**, *4*, 452–456.

(54) Zheng, W.; Feng, W.; Zhang, X.; Chen, X. S.; Chen Liu, G. B.; Qiu, Y. F.; Hasan, T.; Tan, P. H.; Hu, P. A. Anisotropic Growth of Nonlayered CdS on MoS<sub>2</sub> Monolayer for Functional Vertical Heterostructures. *Adv. Funct. Mater.* **2016**, *26*, 2648–2654.

(55) Ghamgosar, P.; Rigoni, F.; Kohan, M. G.; You, S. J.; Morales, E. A.; Mazzaro, R.; Morandi, V.; Almqvist, N.; Concina, I.; Alberto Vomiero, A. Self-Powered Photodetectors Based on Core-Shell ZnO-Co<sub>3</sub>O<sub>4</sub> Nanowire Heterojunctions. *ACS Appl. Mater. Interfaces* **2019**, *11*, 23454–23462.

(56) Qin, J. K.; Shao, W. Z.; Xu, C. Y.; Li, Y.; Ren, D. D.; Song, X. G.; Zhen, L. Chemical Vapor Deposition Growth of Degenerate *p*-Type Mo-Doped ReS<sub>2</sub> Films and Their Homo Junction. *ACS Appl. Mater. Interfaces* **2017**, *9*, 15583–15591.

(57) Treusce, J.; Sandroock, R. Energy Band Structure of Selenium and Tellurium. *Phys. Status Solidi B* **1966**, *16*, 487–497.

(58) Bai, F.; Qi, J.; Li, F.; Fang, Y.; Han, W.; Wu, H.; Zhang, Y. A High-Performance Self-Powered Photodetector Based on Monolayer MoS<sub>2</sub>/Perovskite Heterostructures. *Adv. Mater. Interfaces* **2018**, *5*, 1701275.

(59) Ma, C.; Shi, Y. M.; Hu, W. J.; Chiu, M. H.; Liu, Z. X.; Bera, A.; Li, F.; Wang, H.; Li, L. J.; Wu, T. Heterostructured WS<sub>2</sub>/CH<sub>3</sub>NH<sub>3</sub>PbI<sub>3</sub> Photoconductors with Suppressed Dark Current and Enhanced Photodetectivity. *Adv. Mater.* **2016**, *28*, 3683–3689.

(60) Zhou, X.; Zhou, N.; Li, C.; Song, H. Y.; Zhang, Q.; Hu, X. Z.; Gan, L.; Li, H. Q.; Lü, J. T.; Luo, J.; Xiong, J.; Zhai, T. Y. Vertical Heterostructures Based on SnSe<sub>2</sub>/MoS<sub>2</sub> for High Performance Photodetectors. *2D Mater.* **2017**, *4*, 025048.

(61) Ra, H. S.; Kwak, D. H.; Lee, J. S. A Hybrid MoS<sub>2</sub> Nanosheet-CdSe Nanocrystal Phototransistor with a Fast Photoresponse. *Nanoscale* **2016**, *8*, 17223–17230.

(62) Wang, Y.; Tang, Z. Y.; Podsiadlo, P.; Elkasabi, Y.; Lahann, J.; Kotov, N. A. Mirror-Like Photoconductive Layer-by-Layer Thin Films of Te Nanowires: The Fusion of Semiconductor, Metal, and Insulator Properties. *Adv. Mater.* **2006**, *18*, 518–522.